

Yunhui Jiang

References: Prof. Fei Gao, Prof. Xiran Cai

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Education

ShanghaiTech University

M.Sc. in Electronic Science and Technology

Shanghai, China

Sept. 2022 – June 2025

- GPA: 3.48/4.0

- Supervisor: Prof. Fei Gao, Prof. Xiran Cai

- Thesis: Research on photoacoustic ultrasound dual-modal imaging system based on low-cost opto-acoustic window

Xi'an University of Posts and Telecommunications (XUPT)

B.Sc. in Optoelectronic Information Science and Engineering

Xi'an, China

Sept. 2017 – June 2021

- GPA: 3.41/4.0 (Average Score: 85.58/100, Rank: 3/229)

- Thesis: High-Temperature Storage Characteristics of Ga_2O_3 with Ti/Al/Pt/Au Multilayer Ohmic Contacts

Working Papers

1. **Yunhui Jiang**, Fan Zhang, Yuwei Zheng, Ruixi Sun, Xiran Cai*, and Fei Gao*, "Disposable Opto-Acoustic Window Enabled Plug-and-Play Photoacoustic-Ultrasound Dual-modal Imaging", *Optics Letters* (2025) [\[PDF\]](#)
2. Sheng Liao, Ruixi Sun, **Yunhui Jiang**, Fan Zhang, Youshen Xiao, Yuwei Zheng, Hengrong Lan, Fei Gao*, "Photoacoustic tomography of human eye and oxygenation quantification: a feasibility study", *Optics Letters* (2025) **Under Review**
3. Kaili Ren, Minhui Cheng, Liyong Ren, **Yunhui Jiang**, Dongdong Han, Yongkai Wang, Jun Dong, Jihong Liu*, Li Yang*, and Zhanqiang Xi*, "Ultra-broadband conversion of OAM mode near the dispersion turning point in helical fiber gratings", *OSA Continuum* (2020) [\[PDF\]](#)
4. Youshen Xiao, Zhengyuan Zhang, Ruixi Sun, Yiling Shi, Sheng Liao, Fan Zhang, **Yunhui Jiang**, Xiyu Chen, Arunima Sharma, Manojit Pramanik, Yuyao Zhang*, Fei Gao*, "Resolution Enhancement of Under-sampled Photoacoustic Microscopy Images using Neural Representation", *IEEE Transactions on Computational Imaging* (2025) [\[PDF\]](#)

Research Experience

1. Design and Simulation of a Flexible Laser-Induced Ultrasound Patch

Principal Investigator; Ongoing

July 2025 – Present

- Proposed a biocompatible and skin-conformal ultrasound patch concept patterned optical absorbers on flexible substrates for non-invasive neuromodulation
- Applied phased-array principles by encoding spatial phase delays through absorber geometry, enabling programmable beam steering and dynamic acoustic focusing
- Established a k-Wave simulation framework to generate laser-induced ultrasound and visualize acoustic pressure fields in heterogeneous tissue models
- Performed parametric optimization of absorber patterns to balance spatial resolution, acoustic safety, and energy distribution, providing design guidelines for future minimally invasive devices

2. Development of a Plug-and-Play Dual-Modal Photoacoustic–Ultrasound Imaging System

Lead developer; Published in Optics Letters

July 2024 – June 2025

- Designed a compact plug-and-play opto-acoustic window enabling coaxial photoacoustic and ultrasound imaging triggered by a single laser pulse

- Developed a reproducible fabrication process using cost-effective absorber films, enabling robust and scalable device manufacturing
- Integrated a custom high-speed DAQ for stable real-time signal acquisition and delay-and-sum reconstruction
- Demonstrated *ex vivo* and *in vivo* validation, achieving imaging resolutions of $\sim 215 \mu\text{m}$ (PA) and $\sim 91 \mu\text{m}$ (US) with peak SNRs of 37.5 dB (PA) and 29.8 dB (US)

3. Noninvasive Intracranial Pressure (ICP) Monitoring via Transcranial Photoacoustic Imaging

Co-Investigator, Completed Project

Aug. 2024 – Feb. 2025

- Developed a customized photoacoustic imaging platform integrating a tunable near infrared laser, linear-array ultrasound probe, high-speed DAQ and a stabilized transcranial probe mount
- Performed *in vivo* imaging on human volunteers in collaboration with clinicians, synchronizing photoacoustic signals with invasive ICP monitoring for gold-standard validation
- Implemented data analysis pipeline to extract blood oxygenation metrics from reconstructed images
- Built a linear regression model to correlate photoacoustic-derived sO_2 with measured ICP, demonstrating a strong inverse relationship

4. Fabrication and Characterization of Ga_2O_3 -based Thin-Film Devices

Undergraduate Thesis Project, School of Optoelectronic Engineering, XUPT

Dec. 2020 – June 2021

- Deposited $\sim 180 \text{ nm}$ Ga_2O_3 thin films on Si/SiO₂ substrates via RF magnetron sputtering and improved crystallinity through 950 °C annealing
- Executed a cleanroom process flow including photolithography with AZ5214 resist, e-beam evaporation of Ti/Al/Pt /Au electrodes and lift-off process to define circular transmission-line model (CTLM) patterns
- Performed high-temperature annealing, rapid thermal annealing and long-term thermal storage tests to study ohmic contact formation and interface reliability
- Characterized film structure and device performance using XRD, SEM, UV-Vis, Raman spectroscopy and I-V measurements to establish structure–property relationships
- Extracted specific contact resistivity by linear regression of CTLM data and analyzed process-induced variations
- Identified key process limitations such as film porosity and incomplete lift-off and proposed process optimizations including improved sputtering parameters and ultrasonic-assisted lift-off

Awards and Honours

<i>Outstanding Graduate of ShanghaiTech University (Top 10% of Graduates University-wide)</i>	2025
<i>Outstanding Teaching Assistant (Top 10%)</i>	2025
<i>National Graduate Academic Scholarship</i>	2022, 2023, 2024
<i>University-Level Graduate Scholarship</i>	2022, 2023, 2024
<i>Outstanding Graduate of Shaanxi Province (Top 1% of Graduates University-wide)</i>	2021
<i>National Encouragement Scholarship (Awarded to 5 students in the major)</i>	2019, 2020
<i>Outstanding Student Leader (Top 1% of the class)</i>	2019
<i>Shanghai Way-on Semiconductor Co., Ltd. Scholarship</i>	2019

Skills

Programming Language: Matlab, Python, LaTeX, Markdown

Professional software: k-Wave, Solidworks, Comsol Multiphysics, Auto-CAD, Origin

Experimental Skills: RF magnetron sputtering, Photolithography, E-beam evaporation, Lift-off, Thermal annealing

Languages: Mandarin (Native), English (Fluent), French (Experienced)